

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	1	"20070091406".pn.	US-PGPUB; USPAT	OR	ON	2008/03/20 12:11
S2	3840	359/198,210,214,215,224,225,290,292,295,298.cds.	US-PGPUB; USPAT	OR	ON	2008/03/20 12:34
S4	531472	mem moem micromechanical microelectromechanical microelectricalmechanical (micro adj2 mechanical) (micro adj2 electro adj2 mechanical) (micro adj2 electrical adj2 mechanical) dmd micromirror (micro near2 mirror) microlens\$2 (micro near2 lens\$2) lenslet	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:26
S5	145357	S4 and (electrode conduct\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:27
S6	982742	(mov\$3 rotat\$3 pivot\$3 tilt\$3 twist\$3) near3 axis	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:28
S9	18167	S7 and S8	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:29

S8	505163	mem moem micromechanical microelectromechanical microelectricalmechanical (micro adj2 mechanical) (micro adj2 electro adj2 mechanical) (micro adj2 electrical adj2 mechanical) dmd micromirror (micro near2 mirror)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:29
S7	19349	S5 and S6	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:29
S10	15450	S9 and (actuat\$3 driv\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:31
S11	2466	S10 and (S4 same (electrode conduct\$3) same S6)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:32
S13	1528	S2 and S6	US-PGPUB; USPAT	OR	ON	2008/03/20 13:33
S12	6109	S2 S11	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:33
S14	2269	S11 not S13	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/20 13:34

L12	12515	((mem moem micromechanical microelectromechanical microelectricalmechanical (micro adj2 mechanical) (micro adj2 electro adj2 mechanical) (micro adj2 electrical adj2 mechanical) dmd micromirror (micro near2 mirror)).clm.	US-PGPUB; USPAT	OR	ON	2008/03/24 16:27
L15	205973	((mov\$3 rotat\$3 pivot\$3 tilt\$3 twist\$3) near3 axis).clm.	US-PGPUB; USPAT	OR	ON	2008/03/24 16:28
L14	17406	12 or 13	US-PGPUB; USPAT	OR	ON	2008/03/24 16:28
L13	5273	((microlens\$2 (micro near2 lens\$2) lenslet).clm.	US-PGPUB; USPAT	OR	ON	2008/03/24 16:28
L16	32	((adher\$3 adhesion stick\$3) with function with (voltage current)).clm.	US-PGPUB; USPAT	OR	ON	2008/03/24 16:29
L19	2	14 and 15 and 18	US-PGPUB; USPAT	OR	ON	2008/03/24 16:30
L18	1719	((adher\$3 adhesion stick\$3) with (voltage current)).clm.	US-PGPUB; USPAT	OR	ON	2008/03/24 16:30
L17	1	14 and 15 and 16	US-PGPUB; USPAT	OR	ON	2008/03/24 16:30

3/24/08 4:37:16 PM
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